



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Appl. No. : 10/687,116 Conf. No.: 7360
Applicant : Fumito Nariyuki
Filed : October 17, 2003
Art Unit : 1752
Examiner : Chea, Thorl
Docket No. : FS-F03210-01
For : PHOTOTHERMOGRAPHIC MATERIAL AND IMAGE
FORMING METHOD FOR THE PHOTOTHERMOGRAPHIC
MATERIAL

Mail Stop: AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Sir:

In response to the Office action of January 11, 2007, please amend the above-identified application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.